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Applicants: Michael Rumer, Jack Griswold, Tom Dorsh, Michael Ng, David E. Reedy, Paul D. Healey, Michal Danek and Reed W. Rosenberg

Assignee: Novellus Systems, Inc.

Title: PVD Deposition Process For Improved Aluminum Film Performance

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Examiner: Unknown Group Art Unit: Unknown

Docket No.: M-8570 US

San Jose, California
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COMMISSIONER FOR PATENTS
Washington, D. C. 20231

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on October 18, 2000.

Roberta Paxon
Agent for Applicants

10/18/00
Signature

Respectfully submitted,

Roberta Paxon
Roberta P. Saxon
Agent for Applicants
Reg. No. 43,087

LAW OFFICES OF
SKJERVEN MORRILL
MacPHERSON LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979